

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE TECHNIQUES OF THE CHINA CONTROL OF THE CHINA In re Patent Application of: Taiji NODA et al. Serial No. 09/662,358 Filed: September 15, 2000

For: SEMICONDUCTOR DEVICE AND

METHOD FOR FABRICATING THE SAME)

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, DC 20231

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

The documents have been cited in a Notice of Reasons for Rejection issued on December 3, 2002 by the Japan Patent Office for a corresponding Japanese Patent Application.

The documents are being submitted within three (3) months of the filing of this application or entry into the national stage of this application, or before the first Office Action on the merits, whichever is later, therefore no fee or certification is required under 37 C.F.R. § 1.97(b).

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

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The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380(740819-423).

Respectfully submitted,

Donald R. Studebaker

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